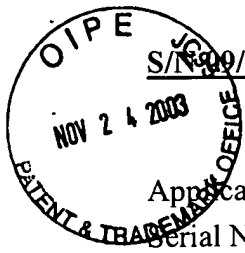


**EXPEDITED PROCEDURE – EXAMINING GROUP 1756**



S/N 09/901001

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Kie Y. Ahn et al.

Examiner: Kathleen Duda

Serial No.: 09/901001

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Title: COPPER ELECTROLESS DEPOSITION TECHNOLOGY FOR ULSI  
METALIZATION

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**RESPONSE UNDER 37 C.F.R. 1.116**

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This paper is filed in response to the final Office Action mailed September 25, 2003.